RYUKA.004AUS PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Takahiro Yamaguchi et al.) Group Art Unit

Serial No. : New Application

Filed : Concurrently Herewith

For : POSITION DETECTION

APPARATUS, POSITION

DETECTION METHOD,

ELECTRONIC PART CARRYING APPARATUS, AND ELECTRONIC

BEAM EXPOSURE APPARATUS

Examiner : Unknown

INFORMATION DISCLOSURE STATEMENT

Hon. Commissioner of Patents and Trademarks Washington, D.C. 20231

Dear Sir:

Enclosed is a form PTO-1449 listing two prior art references relevant to the above-identified application. A copy of the two references and English abstracts is also enclosed herewith.

These prior art references are cited in the International Search Report issued by Japanese Patent Office in the international stage of this case. A copy of the English version of International Search Report is also attached herewith. Since all of the prior art references are non-English documents, an English abstract is attached to each of the references. The prior art references enclosed are:

(1) Japanese Patent Laid-Open Publication No. 07-159056 is relevant to the present invention because it discloses a

Serial No. : New Application

Filed : Concurrently Herewith

process of radiating electron beam on a semiconductor integrate circuit device.

(2) Japanese Patent Laid-Open Publication No. 10-134184 is relevant to the present invention because it discloses a pattern detecting device to detect whether a particular pattern is part of a registered pattern.

Applicant respectfully requests that the prior art references submitted be considered in the substantive examination of this application.

Respectfully submitted,
MURAMATSU & ASSOCIATES

Dated:

By:

Yasuo Muramatsu

Registration No. 38,684

Attorney of Record

7700 Irvine Center Drive Suite 225, Irvine, CA 92618

(949) 753-1127

IDS-RY04.001 111503

	e type a plus sign (+) inside th	<u> </u>	ersons are required to n	U.S. Patent and Tradem.	PTO/SB/08A (08-00) ved for use through 10/31/2002. OMB 0651-0031 ark Office: U.S. DEPARTMENT OF COMMERCE on unless it contains a valid OMB control number.	•	
(Substitute for form 1449/			Complete if Known			
	NEODILLEION DIOC. CONT.		Application Number				
	INFORMATION			Filing Date	11/15/2003		
1	STATEMENT	「BY AP	PLICANT	First Named Inventor	Takahiro Tamaguchi		
- 1				Group Art Unit			
L	(use as many	sheets as ne	cessary)	Examiner Name			
- (Sheet	of	1	Attorney Docket Number	DYUKA 100 Aug		

	U.S. PATENT DOCUMENTS								
Examiner Initials	Cite No.1	U.S. Patent Document Number Kind Code² (if known)		Name of Patentee or Applicant	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear			
					<u> </u>	·			
					<u> </u>				
					 	· · · · · · · · · · · · · · · · · · ·			
				·	 				
						·			
i									
•									
						·			
		. <u></u>							
					 	·			
					<u> </u>				
 -}									

				FOR	EIGN PATENT DOCUMEN	TS		
Examiner Initials*	Cite No.1	Foreign Patent Document Kind Code ³ Office ³ Number ⁴ (if known)		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Te	
		50	5-159056	>	Sumitano Yamatake	6/25/1993		
		132	10-134184		Camatoke	5/22/1998		
	_	<u> `</u>						1
	· :-						· · · · · · · · · · · · · · · · · · ·	╀┦
								+
								\Box
							· · · · · · · · · · · · · · · · · · ·	1_1
			<u> </u>		;			┼╌┤
			,					

	 <u> </u>				
Examiner	 	,	Date		
Signature			Considered	·	
Olgitature			Considered		

Burden Hour Statement: This form is estimated to take 2.0 hours to complete. Time will vary depending upon the needs of the individual case. Any comments on the amount of time you are required to complete this form should be sent to the Chief Information Officer, U. S. Patent and Trademark Office, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Assistant Commissioner for Patents, Washington, DC 20231.

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.